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(54) **TOUCH DEVICES AND FABRICATION METHODS THEREOF**

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H01H 25/00 (2006.01)

H01H 25/04 (2006.01)

G06F 3/044 (2006.01)

(52) **U.S. Cl.**

CPC **G06F 3/044** (2013.01); **H01H 13/70** (2013.01); **G06F 2203/04103** (2013.01); **G06F 2203/04111** (2013.01)

(58) **Field of Classification Search**

CPC H01H 1/00; H01H 13/70; H01H 13/702; H01H 13/703; H01H 13/704; H01H 2239/074; H01H 2203/008; H01H 2207/01; H01H 2221/00; H01H 2231/002; H01H 2231/012; H01H 2231/016; H01H 2231/052; H01H 2239/006

USPC 200/600, 46, 5 R, 5 A, 292, 243; 345/173
See application file for complete search history.

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(57) **ABSTRACT**

A touch device and a fabrication method thereof are provided. The touch device includes a cover lens, a first light shielding pattern and a touch sensing element disposed on the cover lens, a passivation layer covering the touch sensing element and the first light shielding pattern, and a second light shielding pattern disposed on the passivation layer, wherein the second light shielding pattern overlaps with a part of the first light shielding pattern.

18 Claims, 5 Drawing Sheets

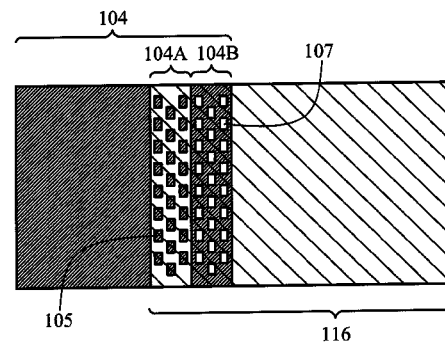
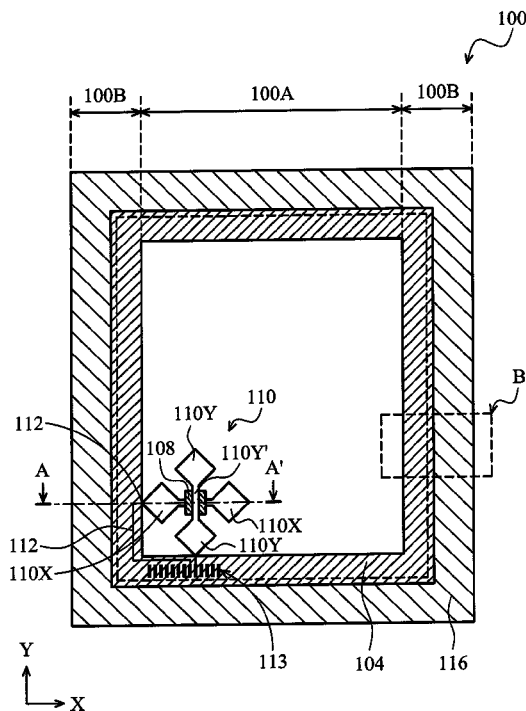


FIG. 1

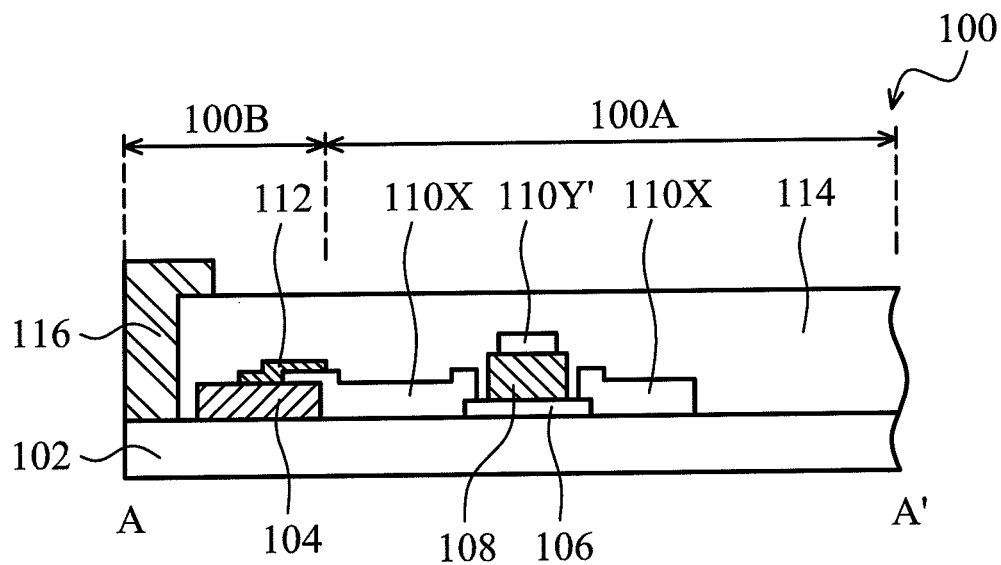


FIG. 2

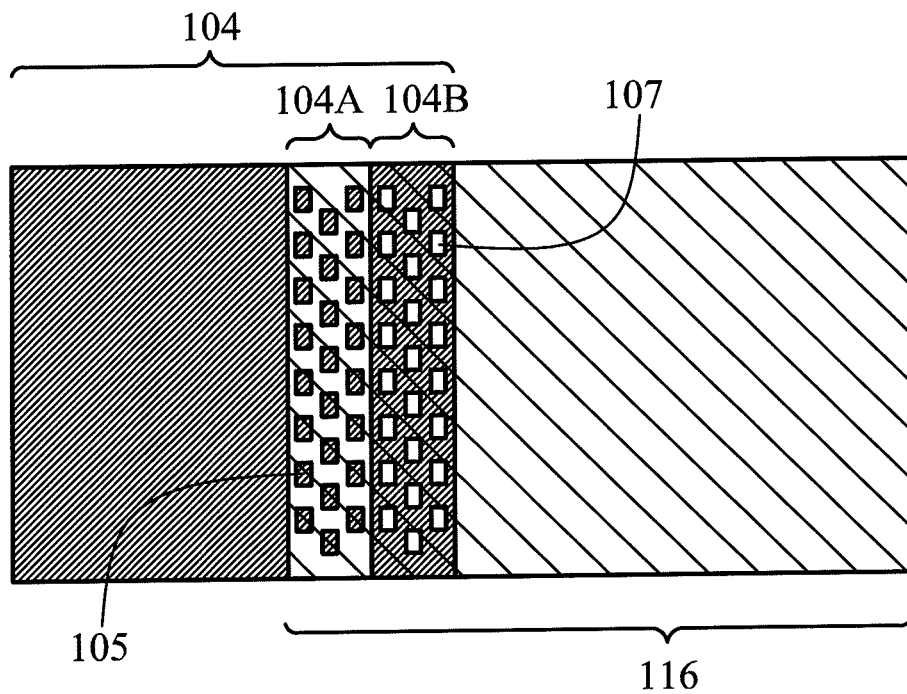


FIG. 3

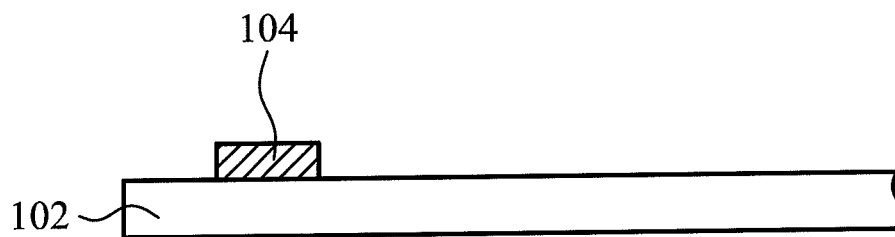


FIG. 4A

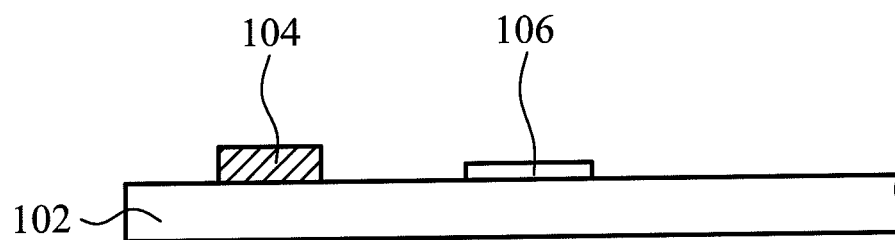


FIG. 4B

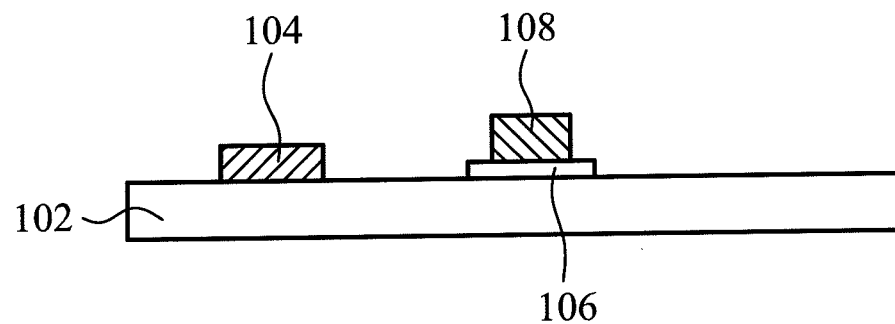


FIG. 4C

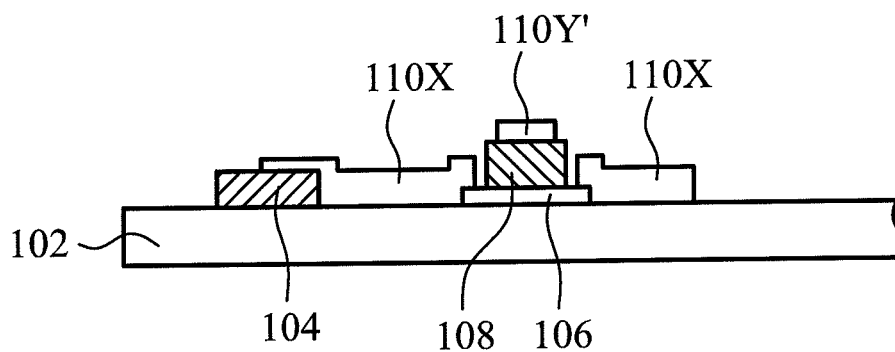


FIG. 4D

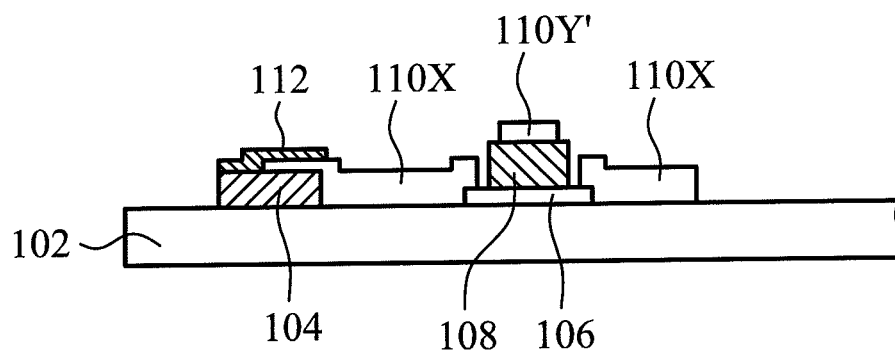


FIG. 4E

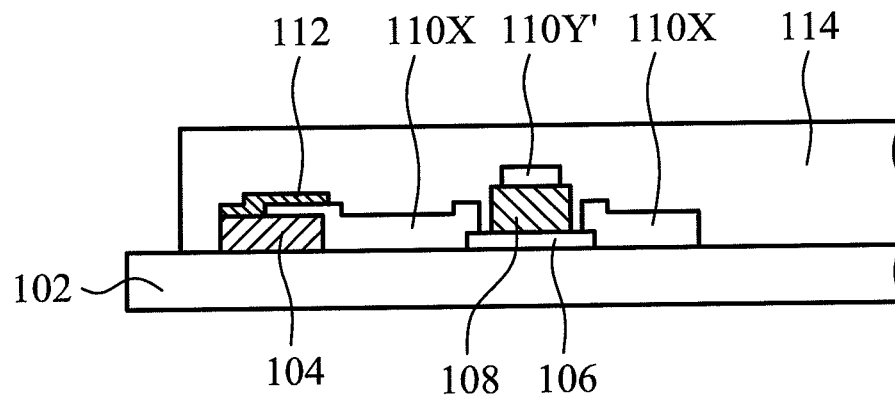


FIG. 4F

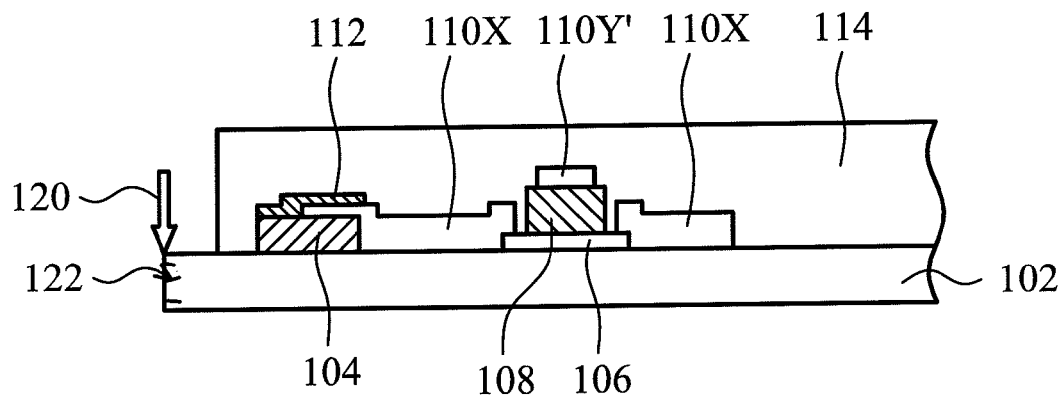


FIG. 4G

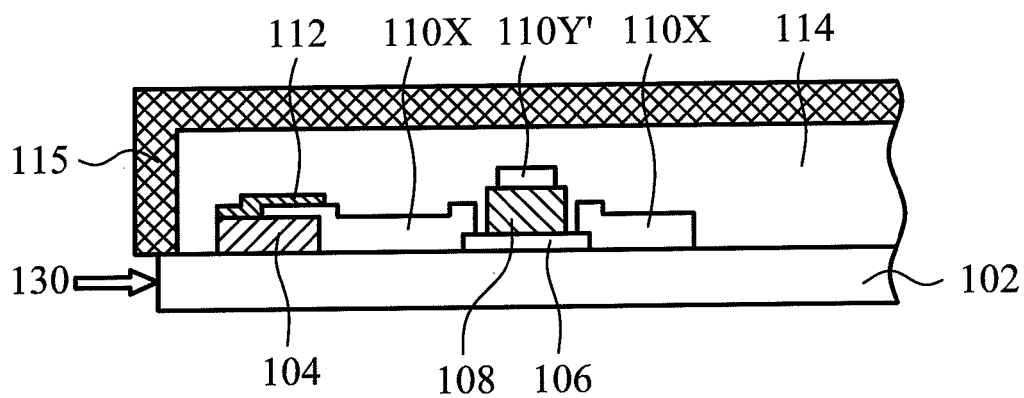


FIG. 4H

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TOUCH DEVICES AND FABRICATION METHODS THEREOF

CROSS REFERENCE TO RELATED APPLICATIONS

This Application claims priority of the People's Republic of China Patent Application No. 201110438680.1, filed on Dec. 19, 2011, the entirety of which is incorporated by reference herein.

BACKGROUND OF THE INVENTION

1. Field of the Invention

The present invention relates to a touch device, and in particular relates to the design and the fabrication of a light shielding pattern of a touch device.

2. Description of the Related Art

In general, a light shielding pattern is formed at a peripheral area of a touch device to cover a touch sensing element and a conductive trace for connecting with an external circuit of the touch device. In conventional touch devices, the light shielding pattern is formed by an exposure and development process. If the conventional touch device wants to change the light shielding pattern, the mask of forming the light shielding pattern also has to be replaced. Thus, this increases the manufacturing cost of conventional touch devices.

Further, after the fabrication of all elements of the touch devices on a glass substrate is completed, a cutting process is performed on the glass substrate. Then, the edges of the cut glass substrate are etched to eliminate cracks in the edges of the cut glass substrate for enhancing the mechanical strength of the glass substrate. In the conventional touch devices, after cutting the glass substrate, the light shielding pattern aligns with the edges of the glass substrate. When an etching process is performed on the edges of the glass substrate, the light shielding pattern is damaged by the etching process. This causes the light shielding pattern to easily be stripped or damaged, thus, if occurring, the process yield of conventional touch devices would be reduced.

BRIEF SUMMARY OF THE INVENTION

Therefore, the embodiments of the invention provide touch devices and methods of fabricating the touch devices, wherein light shielding patterns are formed by two steps of processes. Firstly, a first light shielding pattern is formed by an exposure and development process. Then, a second light shielding pattern is formed by a printing process. Even for different designs of the light shielding patterns, a mask for forming the first light shielding pattern does not need to be replaced. The different designs of the light shielding patterns can be achieved by the printing process of the second light shielding pattern. Thus, this saves the cost of the mask for fabricating the touch devices of the invention. Moreover, according to the embodiments of the invention, after cutting a substrate of a cover lens, the first light shielding pattern is not located on the edges of the substrate of a cover lens. Thus, this is advantageous for subsequent processes to treat the edges of the substrate. The above mentioned problems of the conventional touch devices are overcome and the process yield of the touch devices is enhanced.

According to an illustrative embodiment, a touch device is provided. The touch device comprises a cover lens. A first light shielding pattern is disposed on the cover lens. A touch sensing element is also disposed on the cover lens. A passivation layer is disposed over the touch sensing element and

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the first light shielding pattern. A second light shielding pattern is disposed on the passivation layer, wherein the second light shielding pattern overlaps with a portion of the first light shielding pattern.

According to an illustrative embodiment, a method of fabricating a touch device is provided. The method comprises: providing a substrate; forming a first light shielding pattern on the substrate; forming a touch sensing element on the substrate; forming a passivation layer to cover the touch sensing element and the first light shielding pattern; and forming a second light shielding pattern on the passivation layer, wherein the second light shielding pattern overlaps with a portion of the first light shielding pattern.

A detailed description is given in the following embodiments with reference to the accompanying drawings.

BRIEF DESCRIPTION OF THE DRAWINGS

The present invention can be more fully understood by reading the subsequent detailed description and examples with references made to the accompanying drawings, wherein:

FIG. 1 shows an illustrative top view of a touch device according to an embodiment of the invention;

FIG. 2 shows an illustrative cross section of a portion of a touch device along the cross section line A-A' of FIG. 1 according to an embodiment of the invention;

FIG. 3 shows an illustrative enlarged top view of a first and a second light shielding patterns as shown in the area B of FIG. 1 according to an embodiment of the invention; and

FIGS. 4A-4H show illustrative partial cross sections of several process stages of fabricating the touch device of FIG. 2 according to an embodiment of the invention.

DETAILED DESCRIPTION OF THE INVENTION

The following description is of the best-contemplated mode of carrying out the invention. This description is made for the purpose of illustrating the general principles of the invention and should not be taken in a limiting sense. The scope of the invention is best determined by reference to the appended claims.

Referring to FIG. 1, a top view of a touch device 100 according to an embodiment of the invention is shown. A first light shielding pattern 104 and a second light shielding pattern 116 are disposed in a peripheral area 100B of the touch device 100. The first light shielding pattern 104 does not extend to the edges of a cover lens of the touch device 100. The second light shielding pattern 116 extends to the edges of the cover lens of the touch device 100. The second light shielding pattern 116 overlaps with at least a portion of the first light shielding pattern 104. In one embodiment, the first light shielding pattern 104 can be formed by an exposure and development process. The material of the first light shielding pattern 104 is for example a photo resist. The second light shielding pattern 116 can be formed by a printing process. The material of the second light shielding pattern 116 is for example a printing ink.

A touch sensing element 110 is disposed in a touch sensing area 100A surrounded by the peripheral area 100B of the touch device 100. In one embodiment, the touch sensing element 110 includes a plurality of touch sensing patterns 110X and 110Y. The touch sensing patterns 110X are arranged along a first direction for example an X-axis direction. The touch sensing patterns 110X are separated from each other to form a plurality of intermittent touch sensing lines along the X-axis direction. Further, the touch sensing

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patterns **110Y** are arranged along a second direction perpendicular to the first direction, for example a Y-axis direction. The touch sensing patterns **110Y** are connected with each other through a connecting portion **110Y'** to form a plurality of continuous touch sensing lines along the Y-axis direction. The material of the touch sensing patterns **110X** and **110Y** may be a transparent conductive material, for example indium tin oxide (ITO).

An isolation structure **108** is disposed at the locations of the touch sensing lines formed of the touch sensing patterns **110X** crossing the touch sensing lines formed of the touch sensing patterns **110Y** for electrically isolating a bridge structure (not shown) of the touch sensing patterns **110X** from the connecting portion **110Y'** of the touch sensing patterns **110Y**. This can prevent a short from occurring between the touch sensing lines of the Y-axis direction and the touch sensing lines of the X-axis direction. The material of the isolation structure **108** may be an organic or an inorganic insulating material. The inorganic insulating material is for example silicon oxide or silicon nitride. The organic insulating material is for example an acrylic-base photo resist. Moreover, the touch device **100** further includes a plurality of conductive traces **112**. Touch sensing signals produced from the touch sensing patterns **110X** and **110Y** are delivered to bonding pads **113** of an external circuit through the conductive traces **112**. The external circuit is for example a flexible printed circuit (FPC). The material of the conductive traces **112** may be metal.

Referring to FIG. 2, a cross section of a portion of the touch device **100** along the cross section line A-A' of FIG. 1 according to an embodiment of the invention is shown. The touch device **100** includes a cover lens **102**. The first light shielding pattern **104** is formed on the cover lens **102** and disposed at the peripheral area **100B** of the touch device **100**. The first light shielding pattern **104** is disposed apart from an edge of the cover lens **102** and does not extend to the edge of the cover lens **102**. The bridge structure **106** is formed at the touch sensing area **100A** on the cover lens **102**. Any two adjacent and separated touch sensing patterns **110X** are electrically connected together by the bridge structure **106**. The material of the bridge structure **106** may be a transparent conductive material, for example ITO, or a metal material.

The isolation structure **108** is formed on the bridge structure **106**. The touch sensing patterns **110X** and **110Y** are formed at the touch sensing area **100A** on the cover lens **102**, wherein the connecting portion **110Y'** of the touch sensing patterns **110Y** is formed on the isolation structure **108** and a portion of the touch sensing patterns **110X** stretches over the first light shielding pattern **104**. The conductive trace **112** is formed on the first light shielding pattern **104** and electrically connected with the touch sensing patterns **110X**. In another embodiment, the isolation structure **108** can be disposed on the connecting portion **110Y'** of the touch sensing patterns **110Y** and the bridge structure **106** can be disposed on the isolation structure **108**.

A passivation layer **114** is formed to completely cover the touch sensing patterns **110X** and **110Y**, the first light shielding pattern **104**, the conductive trace **112**, the bridge structure **106** and the isolation structure **108**. Moreover, the passivation layer **114** also covers a side surface of the first light shielding pattern **104**. The material of the passivation layer **114** may be an organic or an inorganic insulating material. The inorganic insulating material is such as silicon oxide or silicon nitride. The organic insulating material is such as an acrylic-base photo resist.

The second light shielding pattern **116** is formed on the passivation layer **114**. The second light shielding pattern **116**

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is disposed at the peripheral area **100B** of the touch device **100** and overlaps with a portion of the first light shielding pattern **104**. Moreover, the second light shielding pattern **116** extends to align with the edge of the cover lens **102**. Furthermore, the second light shielding pattern **116** is extending from the upper surface of the passivation layer **114** to cover the side surface of the passivation layer **114**.

Referring to FIG. 3, an enlarged top view of a portion of the first light shielding pattern **104** and the second light shielding pattern **116** as shown in the area B of FIG. 1 according to an embodiment of the invention is shown. The material of the first light shielding pattern **104** is a photo resist and the material of the second light shielding pattern **116** is a printing ink. Thus, a color difference between the first light shielding pattern **104** and the second light shielding pattern **116** is produced. In order to reduce the color difference between the first light shielding pattern **104** and the second light shielding pattern **116**, in an embodiment, a peripheral portion of the first light shielding pattern **104** is designed to have a first mosaic pattern **104A** and a second mosaic pattern **104B** located at an area of the first light shielding pattern **104** overlapping with the second light shielding pattern **116**. The first mosaic pattern **104A** adjacent to the touch sensing area **100A** has a full portion **105** and the second mosaic pattern **104B** adjacent to the edges of the cover lens has a blank portion **107**. The full portion **105** of the first mosaic pattern **104A** is complementary to the blank portion **107** of the second mosaic pattern **104B** in the patterns. The second light shielding pattern **116** covers the first mosaic pattern **104A** and the second mosaic pattern **104B** of the first light shielding pattern **104**, thereby reducing the color difference between the first light shielding pattern **104** and the second light shielding pattern **116**.

In another embodiment, there is no mosaic pattern existing at the area of the first light shielding pattern **104** overlapping with the second light shielding pattern **116**. The touch device can display another appearance by the color difference between the first light shielding pattern **104** and the second light shielding pattern **116**.

FIGS. 4A-4H show partial cross sections of several process stages of fabricating the touch device **100** of FIG. 2 according to an embodiment of the invention. Referring to FIG. 4B, firstly, a substrate used as the cover lens **102**, for example a glass substrate, is provided. Then, the first light shielding pattern **104** is formed on the cover lens **102** by exposure and development processes. For example, a black photo resist is provided on the cover lens **102**, and then the exposure process is performed on the black photo resist with a pattern of a photo mask. Next, the development process is performed on the black photo resist to form the first light shielding pattern **104**. The first light shielding pattern **104** is formed at the peripheral area **100B** of the touch device **100**.

Referring to FIG. 4B, the bridge structure **106** is formed on the cover lens **102**. In one embodiment, the material of the bridge structure **106** is ITO. Firstly, a first ITO layer is deposited on the cover lens **102**. Then, photolithography and etching processes are performed on the first ITO layer to form the bridge structure **106**. The bridge structure **106** is located at the touch sensing area **100A** of the touch device **100**. Next, referring to FIG. 4C, the isolation structure **108** is formed on the bridge structure **106**. The material of the isolation structure **108** may be an organic or an inorganic insulating material. The inorganic insulating material is for example silicon oxide or silicon nitride. The organic insulating material is for example an acrylic-base photo resist. When the material of the isolation structure **108** is the acrylic-base photo resist, the isolation structure **108** can be formed by exposure and development processes.

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Referring to FIG. 4D, a second ITO layer is deposited on the cover lens 102, and then photolithography and etching processes are performed on the second ITO layer to form the touch sensing patterns 110X and 110Y. The connecting portion 110Y' of the touch sensing patterns 110Y is formed on the isolation structure 108. Any two adjacent touch sensing patterns 110X in the same row are electrically connected with each other through the bridge structure 106. A portion of the touch sensing patterns 110X stretches over the first light shielding pattern 104.

Referring to FIG. 4E, the conductive trace 112 is formed on the first light shielding pattern 104. A portion of the conductive trace 112 extends over the touch sensing pattern 110X. Thus, the conductive trace 112 is electrically connected with the touch sensing pattern 110X. The material of the conductive trace 112 may be metal. For example, a metal layer is deposited above the cover lens 102, and then photolithography and etching processes are performed on the metal layer to form the conductive trace 112.

Referring to FIG. 4F, the passivation layer 114 may be formed above the cover lens 102 by exposure and development processes. The passivation layer 114 completely covers the touch sensing patterns 110X and 110Y, the first light shielding pattern 104, the conductive trace 112, the bridge structure 106 and the isolation structure 108.

Referring to FIG. 4G, after forming the passivation layer 114, the glass substrate used for the cover lens 102 is cut by a cutting process 120. After the cutting process 120, cracks 122 may be produced on the edges of the glass substrate.

Referring to FIG. 4H, in order to eliminate the cracks 122 on the edges of the glass substrate to enhance the strength of the cover lens 102, an etching process 130 is performed on the edges of the glass substrate with hydrofluoric acid (HF). Before performing the etching process 130, a protective film 115 is provided on the upper surface of the side surfaces of the passivation layer 114. This can prevent all elements on the cover lens 102 from damage during the etching process 130. The material of the protective film 115 is for example a stripable coating.

In the embodiments of the invention, after cutting the glass substrate, the first light shielding pattern 104 does not extend to the edges of the glass substrate. Therefore, during the process of etching the edges of the glass substrate, the first light shielding pattern 104 is not damaged by the etching process. In addition, because the first light shielding pattern 104 does not extend to the edges of the glass substrate, the protective film 115 can be attached on the side surface of the passivation layer 114 and does not contact the first light shielding pattern 104. According to the embodiments of the invention, during the etching process 130, the protective film 115 can effectively protect the elements of the touch device 100.

Next, the protective film 115 is removed. Then, the second light shielding pattern 116 is formed on the passivation layer 114 by a printing process to complete the touch device 100 of FIG. 2. Meanwhile, the second light shielding pattern 116 further covers the side surfaces of the passivation layer 114. In one embodiment, the second light shielding pattern 116 overlaps with a portion of the first light shielding pattern 104. In another embodiment, the second light shielding pattern 116 may completely cover the first light shielding pattern 104, but does not cover the touch sensing area 100A of the touch device 100. In addition, while the second light shielding pattern 116 is formed by a printing process, a trademark (not shown) also can be formed on the touch device 100 by the printing process.

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In the conventional touch devices, a light shielding pattern is formed by exposure and development processes. When the pattern design of the light shielding pattern is changed, the photo mask used for forming the light shielding pattern also requires replacement. However, according to the embodiments of the invention, when the pattern design of the light shielding pattern is changed, the photo mask used for forming the first light shielding pattern does not require replacement. The only requirement is to change the printing pattern of the second light shielding pattern to achieve the new pattern design of the light shielding pattern. Therefore, compared with conventional touch devices, the embodiments of the invention can reduce the fabrication cost of the touch devices.

Moreover, in the conventional touch devices, after cutting the glass substrate used for the cover lens, the light shielding pattern is aligned with the edges of the glass substrate. Thus, during the process of etching the edges of the glass substrate, it is easy for the light shielding pattern of the conventional touch device to be damaged. However, according to the embodiments of the invention, after cutting the glass substrate used for the cover lens, the first light shielding pattern is disposed apart from the edges of the glass substrate. Thus, during the process of etching the edges of the glass substrate, the first light shielding pattern of the embodiments of the invention is not damaged. Therefore, compared with conventional touch devices, the embodiments of the invention can enhance the fabrication yield of the touch devices.

While the invention has been described by way of example and in terms of the preferred embodiments, it is to be understood that the invention is not limited to the disclosed embodiments. To the contrary, it is intended to cover various modifications and similar arrangements (as would be apparent to those skilled in the art). Therefore, the scope of the appended claims should be accorded the broadest interpretation so as to encompass all such modifications and similar arrangements.

What is claimed is:

1. A touch device, comprising:

- a cover lens;
- a first light shielding pattern disposed on the cover lens;
- a touch sensing element disposed on the cover lens;
- a passivation layer disposed over the touch sensing element and the first light shielding pattern; and
- a second light shielding pattern disposed on the passivation layer and overlapping a portion of the first light shielding pattern, wherein the portion of the first light shielding pattern overlapping with the second light shielding pattern comprises a first mosaic pattern and a second mosaic pattern.

2. The touch device of claim 1, wherein the material of the first light shielding pattern comprises a photo resist.

3. The touch device of claim 1, wherein the material of the second light shielding pattern comprises a printing ink.

4. The touch device of claim 1, wherein the passivation layer covers a side surface of the first light shielding pattern.

5. The touch device of claim 1, wherein the first mosaic pattern has a full portion.

6. The touch device of claim 1, wherein the second mosaic pattern has a blank portion.

7. The touch device of claim 1, wherein the touch sensing element comprises a plurality of first touch sensing patterns arranged along a first direction, wherein the first touch sensing patterns are separated from each other.

8. The touch device of claim 7, wherein the touch sensing element further comprises a bridge structure disposed between any two adjacent first touch sensing patterns.

9. The touch device of claim 7, wherein the touch sensing element further comprises a plurality of second touch sensing

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patterns arranged along a second direction perpendicular to the first direction, wherein the second touch sensing patterns are connected with each other.

10. The touch device of claim **9**, wherein the touch sensing element further comprises an isolation structure disposed above or under a connecting part of any two adjacent second touch sensing patterns.

11. The touch device of claim **7**, further comprising a plurality of conductive traces disposed on the first light shielding pattern.

12. A method of fabricating a touch device, comprising:
 providing a substrate;
 forming a first light shielding pattern on the substrate;
 forming a touch sensing element on the substrate;
 forming a passivation layer to cover the touch sensing element and the first light shielding pattern;
 cutting the substrate;
 providing a protective film on an upper surface and a side surface of the passivation layer;
 etching an edge of the cut substrate; and
 forming a second light shielding pattern on the passivation layer and to overlap a portion of the first light shielding pattern.

13. The method of claim **12**, wherein the step of forming the first light shielding pattern comprises:
 providing a black photo resist on the substrate; and
 performing exposure and development processes on the black photo resist.

14. The method of claim **12**, wherein the step of forming the touch sensing element comprises:
 depositing a first transparent conductive material layer on the substrate;

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performing photolithography and etching processes on the first transparent conductive material layer to form a bridge structure;

forming an isolation structure on the bridge structure;
 depositing a second transparent conductive material layer on the substrate; and

performing photolithography and etching processes on the second transparent conductive material layer to form a plurality of first touch sensing patterns arranged along a first direction and a plurality of second touch sensing patterns arranged along a second direction perpendicular to the first direction, wherein the first touch sensing patterns are separated from each other and the second touch sensing patterns are connected with each other.

15. The method of claim **14**, wherein any two adjacent first touch sensing patterns are electrically connected together by the bridge structure and a connecting part of any two adjacent second touch sensing patterns is formed on the isolation structure.

16. The method of claim **14**, further comprising:
 depositing a metal layer on the first light shielding pattern;
 and
 performing photolithography and etching processes on the metal layer to form a plurality of conductive traces on the first light shielding pattern.

17. The method of claim **12**, further comprising:
 removing the protective film; and
 printing the second light shielding pattern on the passivation layer.

18. The touch device of claim **1**, wherein the second light shielding pattern covers a side surface of the passivation layer.

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